APPARATUS AND METHOD FOR ESTIMATING MOVEMENT IN MOVING IMAGEPROCESSING

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Abstract of JP 9168152 (A)

PROBLEM TO BE SOLVED: To improve the performance for motion estimation by combining a global motion estimate PROBLEM TO BE SOLVED: To improve the performance for motion estimation by combining a global motion estimate system with a local motion estimation system. SOLUTION: A global motion estimation (EVG) section 103 applies an EVG method to an object received via a video image input section 101 and an object mask output section 102 to estimate a motion. A local area selection section(LAS) 104 divides the EVG area based on an output of the object mask output section 102 to select an estimate area for a local motion estimate (EVL). A 1st EVL section 105 applies the EVL method by using, e.g. a 6-parameter model to an output of the LAS 104 thereby estimating the motion. A 2nd EVL section 106 applies the EVL method by using, e.g. an independent 2-parameter model to the output of the LAS 104 thereby estimating the motion. A control section 107 selects an output offering more excellent estimate performance from outputs of the 1st and 2nd EVL sections 105, 106. of the 1st and 2nd EVL sections 105, 106.



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